

Notice of References Cited	Application/Control No. 10/582,578	Applicant(s)/Patent Under Reexamination WIMBERGER-FRIEDL ET AL.	
	Examiner BENJAMIN SCHIFFMAN	Art Unit 1791	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Hanemann et al., Micro- and Nanopatterning Polymers, "Molding of Polymeric Microstructures", 01 September 1998, pp. 67-75, http://dx.doi.org/10.1021/bk-1998-0706.ch006
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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